## AMENDMENT(S) TO THE CLAIMS

1. (Currently Amended) An optical interconnect for a fiber optic system, comprising:

an optoelectronic device selected from the group consisting of a top emitting vertical cavity surface emitting laser (VCSEL) and a bottom emitting VCSEL; and

a penetrator made of a suitable optically transmissive material optically coupled to etched into a substrate of the optoelectronic device and configured for insertion along the length of an optical fiber for transferring light between the optical fiber and the optoelectronic device.

- 2. (Original) The interconnect of Claim 1 wherein the penetrator has a pyramidal shape.
- 3. (Original) The interconnect of Claim 1 wherein the penetrator has a conical shape.

## 4-5 (Canceled)

- 6. (Original) The interconnect of Claim 1 wherein the penetrator has at least one wall coated with a material that minimizes reflection of light back into the optoelectronic device.
- 7. (Original) The interconnect of Claim 1 wherein the penetrator has at least one wall coated with a material that facilitates coupling of light from the optoelectronic device to the optical fiber.
- 8. (Original) The interconnect of Claim 1 and further comprising an optical fiber having the penetrator pierced therein to optically couple the optoelectronic device and the optical fiber.
- 9. (Previously Amended) The interconnect of Claim 8 and further comprising an encapsulation layer at least partially surrounding the optoelectronic device and the penetrator.

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- 10. (Original) The interconnect of Claim 1 and further comprising a plastic optical fiber, and wherein the penetrator is inserted along the length of the plastic optical fiber at least halfway across a diameter of the optical fiber.
- 11. (Currently Amended) A An parallel optical interconnect for a fiber optic system, comprising:

a plurality of optoelectronic devices arranged in a linear array selected from the group consisting of a top emitting vertical cavity surface emitting laser (VCSEL) and a bottom emitting VCSEL; and

a plurality of penetrators each made of a suitable optically transmissive material and optically coupled to etched into a substrate of a corresponding one of the optoelectronic devices and configured for insertion along the length of a corresponding plastic optical fiber of a side-by-side array of a plurality of plastic optical fibers for transferring light between the optical fibers and the corresponding optoelectronic devices.

- 12. (Original) The interconnect of Claim 11 wherein each penetrator has a pyramidal shape.
- 13. (Original) The interconnect of Claim 11 wherein each penetrator has a conical shape.

## 14-15 (Canceled)

- 16. (Original) The interconnect of Claim 11 wherein each penetrator has at least one wall coated with a material that minimizes reflection of light back into the corresponding optoelectronic device.
- 17. (Original) The interconnect of Claim 11 wherein each penetrator has at least one wall coated with a material that facilitates coupling of light from the optoelectronic device to the corresponding optical fiber.

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- 18. (Original) The interconnect of Claim 11 and further comprising a plurality of optical fibers each having a corresponding one of the penetrators pierced therein to optically couple each optoelectronic device to its corresponding optical fiber.
- 19. (Previously Amended) The interconnect of Claim 18 and further comprising an encapsulation layer at least partially surrounding the optoelectronic devices and the penetrators.
- 20. (Original) The interconnect of Claim 11 wherein the optoelectronic devices are attached to a support selected from the group consisting of a common ceramic substrate, a common silicon substrate and a common integrated circuit.

## 21. (Canceled)

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- 22. (Allowed) An optical interconnect for a fiber optic system, comprising: an optoelectronic device; and
- a penetrator made of a suitable optically transmissive material etched into a substrate of
- the optoelectronic device, the penetrator being optically coupled to the optoelectronic device and configured for insertion along the length of an optical fiber for transferring light between the
- 6 optical fiber and the optoelectronic device.
  - 23. (Allowed) An parallel optical interconnect for a fiber optic system, comprising: a plurality of optoelectronic devices arranged in a linear array; and
  - a plurality of penetrators each made of a suitable optically transmissive material and
- etched into a substrate of a corresponding one of the optoelectronic devices, the penetrators being optically coupled to the corresponding optoelectronic devices and configured for insertion
- along the length of a corresponding plastic optical fiber of a side-by-side array of a plurality of plastic optical fibers for transferring light between the optical fibers and the corresponding
- 8 optoelectronic devices.